

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Confirmation No. 4091

Kazuto HIROKAWA et al. : Docket No. 2003_0961A

Serial No. 10/617,794 : Group Art Unit 3723

Filed July 14, 2003 : Examiner Eileen P. Morgan

SUBSTRATE POLISHING APPARATUS: Mail Stop: Amendment

AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action of May 18, 2005, please amend the above-identified U.S. Patent application as follows:

ZŦW